



28-71

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

11/04/04

APPLICANT: T. TSUJIMURA et al.

SERIAL NO.: 09/682,002

ART UNIT: 2871

FILED: 07/06/2001

EXAMINER: Tai V. DUONG

TITLE: ACTIVE MATRIX SUBSTRATE AND MANUFACTURING METHOD

THEREOF

ATTORNEY DOCKET NO.: JP920000098US1

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT AND  
CERTIFICATION UNDER 37 C.F.R. 1.97(e) (1)

Sir:

Pursuant to the duty of disclosure, the attention of the Examiner is directed to the documents cited on the attached form PTO-1449 (substitute). These four documents were cited in Applicants' corresponding application in Japan in an office action issued on August 19, 2003. Copies of these documents, including abstracts in English, as well as a copy of the Japanese office action are enclosed herewith. The latter indicates, by reference to specific numbers, the claims and the documents of relevance. It is respectfully requested that the Examiner considered these documents, and make them of record.

I hereby certify that each item of information contained in this information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

It is believed that no fee is required for the filing of this paper. However, if any fee is required please charge deposit account no. 50-0510.

Respectfully submitted,

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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<b>INFORMATION DISCLOSURE CITATION FORM FOR PATENT APPLICATION (FORM PTO-1449) (Substitute)</b>		Docket No.: JP920000098US1		Serial No.: 09/682,002		
		Applicant(s): Tsujimura et al.				
		Filing Date: 07/06/01		Group: 2871		
<b>U.S. PATENTS</b>						
Initials	Patent Number	Issue Date	Name	Class	Sub-class	Filing date
<b>FOREIGN PATENT DOCUMENTS</b>						
Initials	Document Number	Date	Country	Name		Translation? Yes/No/n/a
	08-201849	08/1996	Japan	Masatoshi et al.		Yes
	05-113580	05/1993	Japan	Noritoshi et al		Yes
	61-161764	07/1986	Japan	Yoshiharu		Yes
	61-188967	08/1986	Japan	Tadanori et al.		Yes
<b>OTHER DOCUMENTS (Title, Author, Date, Pages, Etc., if known)</b>						
Examiner's Signature:				Date Considered:		
Initial if reference was considered, whether or not citation is in conformance with MPEP. Mark through citation if not considered. Include a copy of this citation form with your next correspondence to the Applicant(s).						